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Contents

- v Authors
- vii Symposium Committees
- xi Conference Committee

PLASMONIC-ENHANCED SENSING AND LIGHT HARVESTING II

11194 05 Metamaterial absorber-empowered light-harvesting devices [11194-4]

HOT CARRIER DYNAMICS, PHOTOCATALYSIS, AND PHOTOTHERMAL EFFECTS IN PLASMONIC NANOSTRUCTURES I

11194 09 Au nanoparticle controlled luminescence emission of single NaYF4:Eu³⁺ particle (Invited Paper) [11194-8]

HOT CARRIER DYNAMICS, PHOTOCATALYSIS, AND PHOTOTHERMAL EFFECTS IN PLASMONIC NANOSTRUCTURES II

11194 0A Gap mode induced photocatalytic reactions of p-methyl thiophenol and relating molecules (Invited Paper) [11194-9]

GRAPHENE, ACTIVE, AND MULTIDISCIPLINARY PLASMONICS II

- 11194 0H Optical tuning of terahertz plasmonic resonances in graphene-based heterostructures (Invited Paper) [11194-16]
- 11194 0J Synthesis and luminescence properties of rare-earth doped NaLaF4 nanoparticles [11194-18]
- 11194 0K Enhancement of up- and downconversion photoluminescence from Yb³⁺, Er³⁺ co-doped CaF₂ nanoparticles deposited on two-dimensional plasmonic arrays [11194-19]

POSTER SESSION

11194 OL Surface-enhanced Raman spectroscopy of organoluminophores adsorbed on quartz surfaces modified by hydrosols of silver and gold nanoparticles [11194-20]

- 11194 0M Near-field imaging and revealing dynamics of ultrafast surface plasmons using photoemission electron microscopy [11194-21]
- 11194 OR **Dynamically tunable perfect absorbers based on periodic microstructures** [11194-26]
- 11194 0U Design of metamaterials using neural networks [11194-29]